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# Infrared optical properties of $Ba(Zr_{0.20}Ti_{0.80})O_3$ and $Ba(Zr_{0.30}Ti_{0.70})O_3$ thin films prepared by sol-gel method

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#### 1. Introduction

Lead-free BaTiO<sub>3</sub> based materials have attracted much attention because of their environmental friendliness, which have a lot of potential application such as capacitive and nonvolatile random memory cell, electro-optic integrated circuits and pyroelectric device [1–3]. Barium zirconium titanate  $BaZr_xTi_{1-x}O_3(BZT)(x = 0.2)$ and 0.3), substitution of Ti by Zr in BaTiO<sub>3</sub>, has better characteristics than BaTiO<sub>3</sub> [4–6], The Zr<sup>4+</sup> ion (atomic radius of 86 pm) is chemically more stable than the Ti<sup>4+</sup> ions (atomic radius of 74.5 pm) and has a larger ionic size to expand the perovskite lattice [7]. It has many merits, like high dielectric constants and low leakage current, controlled Curie temperature. So it will be a very promising ferroelectric material. Recently, BZT thin films with good dielectric characteristics has been prepared by sol-gel method [8,9]. However, some few studies of optical properties in BZT films has been reported in literature [10-13]. Thus, the investigation of infrared optical of BZT thin films is very important to optimize the design and understood of devices based on the pyroelectric and electric-optical properties of BZT thin films.

ABSTRACT

Ba( $Zr_xTi_{1-x}$ )O<sub>3</sub> (BZT) (x = 0.20 and 0.30) thin films are deposited on Pt(1 1 1)/Ti/SiO<sub>2</sub>/Si(1 0 0) substrate by sol-gel method. X-ray diffraction patterns show that the thin films have a good crystallinity. Optical properties of the films in the wavelength range of 2.5–12  $\mu$ m are studied by infrared spectroscopic ellipsometry (IRSE). The optical constants of the BZT thin films are determined by fitting the IRSE data using a classical dispersion formula. As the wavelength increases, the refractive index decreases, while the extinction coefficients increase. The effective static ionic charges are derived, which are smaller than that in a purely ionic material for the BZT thin films.

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Spectroscopic ellipsometry is a nondestructive and powerful technique to investigate the optical characteristics of materials. It is able to measure the thickness and the dielectric function of a multilayer system simultaneously.

In this paper, we report the optical properties of  $Ba(Zr_xTi_{1-x})O_3$ thin films, with x = 0.20 and 0.30 on platinized silicon Pt(1 1 1)/Ti/ SiO<sub>2</sub>/Si(1 0 0) substrates by infrared spectroscopic ellipsometry (IRSE) in the wavelength range of 2.5–12  $\mu$ m. We assume a threelayer model (ambient/BZT/Pt) for obtention of data of IRSE.

#### 2. Experimental procedure

The Ba( $Zr_xTi_{1-x}$ )O<sub>3</sub> thin films with x = 0.20 and 0.30 on Pt(1 1 1)/ Ti/SiO<sub>2</sub>(1 0 0)/Si(1 0 0) substrates were fabricated by sol-gel method. The starting materials were barium acetate [Ba(CH<sub>3</sub>-COO)<sub>2</sub>, 99% (Aldrich)], zirconium isopropoxide [Zr(OC<sub>3</sub>H<sub>7</sub>)<sub>4</sub>, 99.9% (Aldrich)] and titanium isopropoxide [Ti(OC<sub>3</sub>H<sub>7</sub>)<sub>4</sub>, 97% (Aldrich)]. Glacial acetic acid [CH<sub>3</sub>COOH, 99.5% (SUZHOU SANJIE in China)], 2methoxyethanol [C<sub>3</sub>H<sub>8</sub>O<sub>2</sub>, 99% (Aldrich)] and ethylene glycol [C<sub>2</sub>H<sub>6</sub>O<sub>2</sub>, 99% (Aldrich)] were used as the solvents and polymerizing agents, respectively. [Ba(CH<sub>3</sub>COO)<sub>2</sub>] was dissolved into heated [CH<sub>3</sub>COOH]. This was followed by an addition of [Ti(OC<sub>3</sub>H<sub>7</sub>)<sub>4</sub>] and [Zr(OC<sub>3</sub>H<sub>7</sub>)<sub>4</sub>] under constant stirring. The mixture was added with [C<sub>2</sub>H<sub>6</sub>O<sub>2</sub>] to form a stock solution. The spin-on solution was prepared by diluting the stock solution with equi-volume amounts



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of glacial acetic acid and 2-methoxyethanol to become 0.3 M in concentration. After aging the hydrolyzed solution for 24 h, thin films deposition was carried out on Pt(1 1 1)/Ti/SiO<sub>2</sub>/Si(1 0 0) substrates by spin coating three layers at 3000 rpm for 30 s. the wet films were dried and annealed on a hot plate for 5 min at 500 °C. The crystalline structure of thin films was identified by X-ray diffraction using a SIMENS D-5000 Power Diffractometer. The ellipsometric measurements were carried out by a variable-angle infrared spectroscopic ellipsometer by synchronously rotating the polarized and analyzer with a speed ratio of 1:1. The accuracy was better than 1% for tan  $\Psi$  and cos  $\Delta$  in the measurements. The incident angle was 70° for the samples.

We describe the dielectric function of BZT thin films in the 2.5–12.5  $\mu$ m wavelength range. This energy is higher than the phonon frequencies, but much lower than the band gap energy of BZT thin film. Complex dielectric function is described as follows [14]:

$$\varepsilon_1 = \varepsilon_{\infty} - \frac{Nq^2}{M^*\varepsilon_0} \frac{\tau^2}{1 + \omega^2 \tau^2}, \qquad \varepsilon_2 = \frac{Nq^2}{M^*\varepsilon_0} \frac{\tau}{\omega(1 + \omega^2 \tau^2)}$$
(1)

where *N* is the cell number per unit volume, *q* is the ionic average effective charge,  $1/M^* = 1/M_+ + 1/M_-$  is the reduced mass of cations  $M_+$  and anions  $M_-$  in a unit cell,  $\tau$  is an energy-independent relaxation time, and  $\omega$  is the light frequency.  $\varepsilon_0$  and  $\varepsilon_\infty$  are the dielectric constants in vacuum and the high-frequency dielectric constant, respectively.

The root mean square fractional error is defined by

$$\sigma^{2} = \frac{1}{2J - K} \sum_{i=1}^{J} \left[ \left( \frac{\Psi_{i}^{\text{mod}} - \Psi_{i}^{\text{exp}}}{\sigma_{\Psi,i}^{\text{exp}}} \right)^{2} + \left( \frac{\Delta_{i}^{\text{mod}} - \Delta_{i}^{\text{exp}}}{\sigma_{\Delta,i}^{\text{exp}}} \right)^{2} \right],$$
(2)

is used to judge the quality of the fit between the experimental and model data, where J is the number of measured  $\Psi$  and  $\Delta$  pairs in the fitting, and K is the number of fit parameters. This equation has 2J in the prefactor because there are two measured values included in the calculation for each  $\Psi$  and  $\Delta$  pair. The standard deviations were calculated from the known error bars on the calibration parameters and the fluctuations of the measured data over averaged cycles of the rotation polarizer and analyzer.

### 3. Results and discussion

Fig. 1 shows the X-ray diffraction patterns of  $Ba(Zr_xTi_{1-x}O)_3$ (*x* = 0.2 and *x* = 0.3) (BZT20, BZT30) thin films on platinized silicon



**Fig. 1.** XRD patterns of BZT thin films on platinized silicon substrates with x = 0.2 and 0.3.



Fig. 2. Experimental (circle dot) and calculated (solid line) IRSE data for BZT20 on a platinized silicon substrate.

substrates. The obvious peaks indicate the BZT thin films have good crystallinity with typical perovskite structure. The nature of the ferroelectric phase transition at the transition temperature  $(T_m)$  of BTZ bulk ceramics is known to change strongly with zirconium (Zr) content. For Zr contents x > 0.08, the Ba(Ti<sub>1-x</sub>Zr<sub>x</sub>)O<sub>3</sub> bulk ceramics show a broad dielectric constant-temperature ( $\varepsilon \sim T$ ) curve near  $T_{\rm m}$ , which is caused by the inhomogeneous distribution of  $Zr^{4+}$  ions on Ti<sup>4+</sup> ions sites and mechanical stress in the grain [15]. As the Zr content increases, the phase transition temperatures approach each other until at a Zr content of  $x \sim 0.20$ , only one phase transition exists [16]. Ravez and Simon [17] have reported that BTZ shows typical relaxor-like behavior when x = 0.25. So the samples of BZT thin films have a cubic lattice. The calculated lattice constants of BZT20 and BZT30 are 4.028 and 4.079 Å, respectively. Pontes et al. [18] reported that this substitution promote an expansion in the unit cell and that the Zr addition at around 25 at.%, making the BZT thin films to crystallize in the cubic structure. Tang et al. [19] showed that BTZ with a high Zr content (with x = 0.30and 0.35) has a slim hysteresis behavior, which is typical of a relaxor ferroelectric owing to the existence of micropolar regions.

The measured IRSE data,  $\Psi$  and  $\Delta$  of BZT thin films on Pt(1 1 1)/ Ti/SiO2/Si(1 1 1) substrates with x = 0.2 and 0.3 in the wavelength range 2.5–12.5 µm are shown in Figs. 2 and 3, respectively. We analyzed these experimental data using a three-phase model [20], as the Pt layer was thick enough and the infrared light could not



Fig. 3. Experimental (circle dot) and calculated (solid line) IRSE data for BZT30 on a platinized silicon substrate.

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